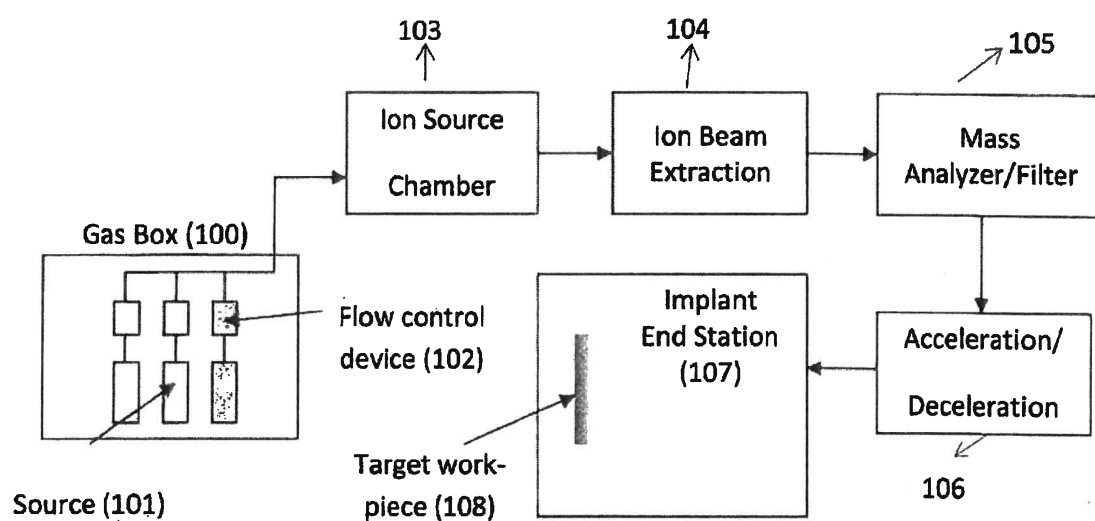
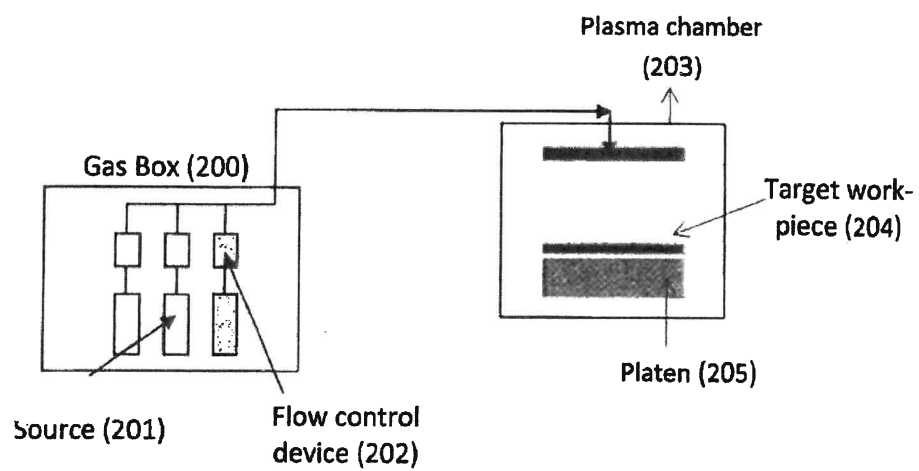




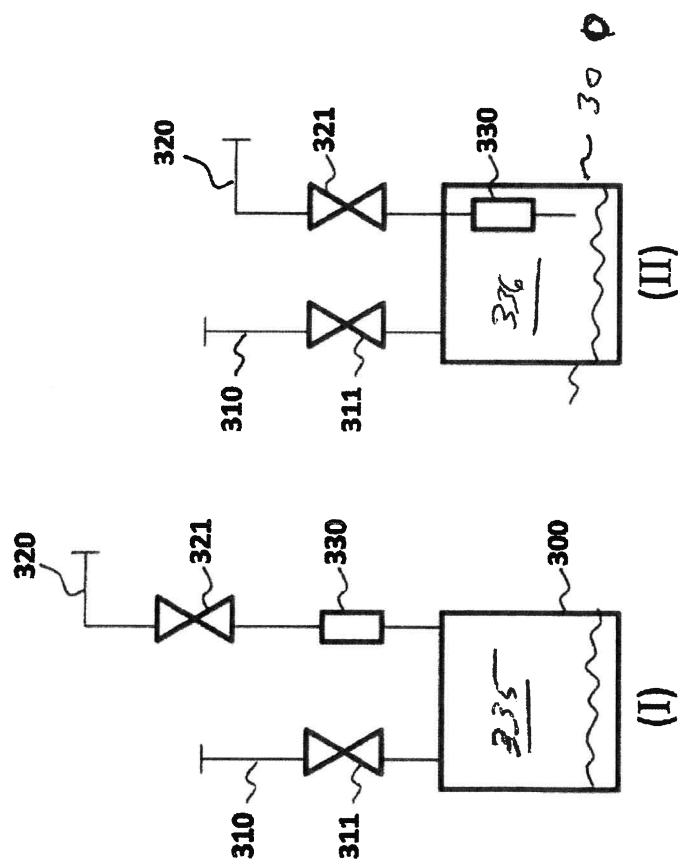
Schematic of beamline ion implant system

FIG. 1



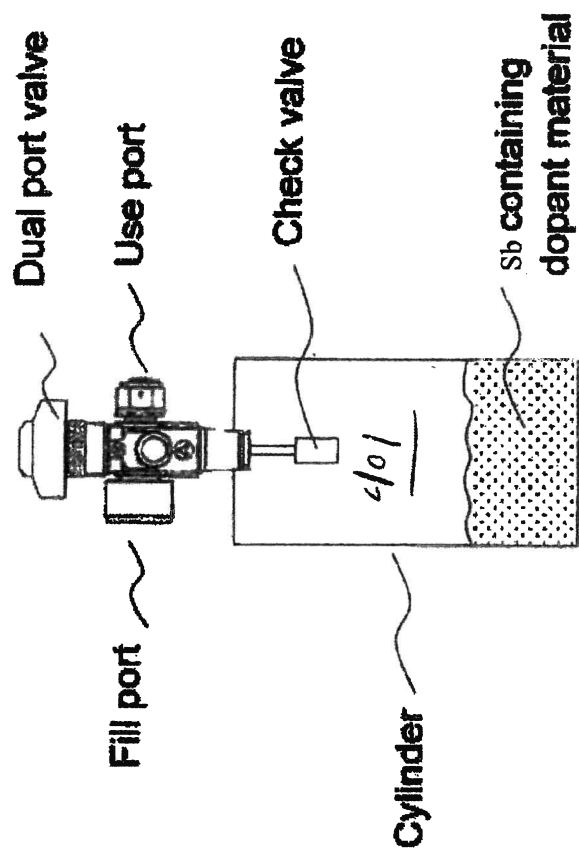
Schematic of plasma immersion ion implant system

FIG. 2



PACKAGE FOR Sb CONTAINING DOPANT MATERIALS

FIG. 3

**FIG. 4**